

PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
Alto Stemmer	06/29/2007
RECEIVING PARTY DATA	
Name:	Siemens Aktiengesellschaft
Street Address:	Wittelsbacherplatz 2
City:	Muenchen
State/Country:	GERMANY
Postal Code:	80333
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	11777338
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ATTORNEY DOCKET NUMBER:	P07,0138 (26965-3847)
NAME OF SUBMITTER:	Pam VanderMeer
Total Attachments: 1 source=P070138_Assignment#page1.tif	

OP \$40.00 11777338

ASSIGNMENT

FOR a valuable consideration, the undersigned,

residing at, **ALTO STEMMER**
Höllgasse 3
91183 Abenberg
Germany

hereby sell, assign and transfer unto **Siemens Aktiengesellschaft**, Wittelsbacherplatz 2, 80333 Muenchen, Germany, a German corporation, the whole right, title and interest in and to a certain invention or improvement in

METHOD AND MAGNETIC RESONANCE APPARATUS FOR DYNAMIC MAGNETIC RESONANCE IMAGING

disclosed in an application for Letters Patent of the United States, prepared by the Patent Department of the Firm Schiff Hardin LLP of Chicago, Illinois, and executed of even date herewith, said application being identified in the office records of said firm as Case No. P07,0138 and in our own records as Case No. 2006P11918US, and in and to the United States Letters Patent therefor, when issued, together with all improvements thereon and betterments thereof, all divisions, continuations and reissues thereof and substitutions of or for said application, and all rights and privileges under the Letters Patent that may be granted therefor, including the right to claim the benefit of an earlier filing date for the same invention in a foreign country.

I hereby authorize and request the Commissioner of Patents to issue the Letters Patent that may be granted for said invention or improvements to said **Siemens Aktiengesellschaft**, Wittelsbacherplatz 2, 80333 Muenchen, Germany.

For the same consideration, I hereby agree that I will promptly communicate to the aforesaid assignee or its assigns full and complete information concerning said improvements or betterments of the inventions disclosed in said application, and will cooperate at any time upon request of said assignee or its assigns, at its expense, in the procurement of patent protection to cover the inventions herein assigned and to be assigned, including the execution of new, divisional, continuing and reissue applications; will make all rightful oaths, will testify in any proceedings in the United States Patent Office or in the Courts, and generally will do everything lawfully possible to aid said assignee, its successors, assigns and nominees to obtain, enjoy and enforce proper patent protection for the inventions embraced within the terms of this document.

DATE: June 29, 2007

Alto Stemmer
ALTO STEMMER

WITNESSES:

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Mathias N. Hluc

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U-27

CHI 5043910.1